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COPY

NISSIN ION EQUIPMENT CO., LTD.

575 KUZE-TONOSHIRO-CHO, MINAMI-KU,
KYOTO-CITY, KYOTO, 601-8205, JAPAN

This is a multi-site certificate, additional site(s) are listed on the next page(s)

Bureau Veritas Certification Holding SAS - UK Branch certifies that the Management System
of the above organisation has been audited and found to be in accordance with the requirements of
the management system standards detailed below

ISO 9001:2015

Scope of certification

- DESIGN, DEVELOPMENT AND MANUFACTURE OF
 - (1) ION IMPLANTATION SYSTEMS FOR SEMICONDUCTOR (I/I)
 - (2) ION IMPLANTATION SYSTEMS FOR SEMICONDUCTOR FPD (FPD)
- PROVISION OF ION IMPLANTATION SERVICES

| | |
|---|------------------------|
| Original cycle start date: | 11-11-1996 |
| Expiry date of previous cycle: | NA |
| Certification / Recertification Audit date: | 04-12-2020 |
| Certification/Recertification Cycle Start Date: | 17-01-2021 |
| Subject to the continued satisfactory operation of the organization's Management System, this certificate expires on: | 16-01-2024 |
| Certificate No. : JP020446 | Version: 2 |
| | Issue Date: 05-04-2022 |



0008

Certification Body Address: 5th Floor, 66 Prescott Street, London, E1 8HG, United Kingdom

*Local office: Bureau Veritas Japan Co., Ltd. Certification Division
KRC bldg. 8F, 18 Nihon-odori, Naka-ku, Yokohama, 231-0021, Japan*

Further clarifications regarding the scope and validity of this certificate, and the applicability of the management system requirements, please call: 045-651-4784





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Scope of certification

| Site Name/Location | Site Address | Site Scope |
|--------------------|---|--|
| KUZE PLANT | 575 KUZE-TONOSHIRO-CHO, MINAMI-KU, KYOTO-CITY, KYOTO, 601-8205, JAPAN | <ul style="list-style-type: none"> DEVELOPMENT OF ION IMPLANTATION SYSTEMS FOR EMICONDUCTOR (I/I) PROVISION OF ION IMPLANTATION SERVICES |
| SHIGA PLANT | 29 HINOKIGAOKA, MINAKUCHI-CHO, KOKA-CITY, SHIGA, 528-0068, JAPAN | <ul style="list-style-type: none"> DEVELOPMENT AND MANUFACTURE OF ION IMPLANTATION SYSTEMS FOR SEMICONDUCTOR (I/I) DESIGN, DEVELOPMENT AND MANUFACTURE OF ION IMPLANTATION SYSTEMS FOR SEMICONDUCTOR FPD (FPD) |
| TOJI OFFICE | 4F GRAND KYOTO, 75 NISHIKUJO-HIGASHIHIEIJO-CHO, MINAMI-KU, KYOTO-CITY, KYOTO, 601-8437, JAPAN | SALE OF ION IMPLANTATION SYSTEMS FOR SEMICONDUCTOR (I/I) AND SEMICONDUCTOR FPD (FPD) |

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